



S/N 10/661,379

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant:	Zhiping Yin et al.	Examiner:	Stephen D. Rosasco
Serial No.:	10/661,379	Group Art Unit:	1756
Filed:	September 12, 2003	Docket:	303.864US1
Title:	TRANSPARENT AMORPHOUS CARBON STRUCTURE IN SEMICONDUCTOR DEVICES		

SUPPLEMENTAL INFORMATION DISCLOSURE STATEMENT

MS Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

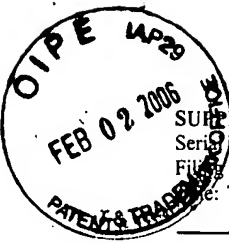
In compliance with the duty imposed by 37 C.F.R. § 1.56, and in accordance with 37 C.F.R. §§ 1.97 *et. seq.*, the enclosed materials are brought to the attention of the Examiner for consideration in connection with the above-identified patent application. Applicants respectfully request that this Supplemental Information Disclosure Statement be entered and the documents listed on the attached Form 1449 be considered by the Examiner and made of record. Pursuant to the provisions of MPEP 609, Applicants request that a copy of the 1449 form, initialed as being considered by the Examiner, be returned to the Applicants with the next official communication.

Pursuant to 37 C.F.R. §1.97(c)(2), Applicants have included the fee of \$180.00 as set forth in 37 C.F.R. §1.17(p). Please charge any additional fees or credit any overpayment to Deposit Account No. 19-0743.

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The Examiner is invited to contact the Applicants' Representative at the below-listed telephone number if there are any questions regarding this communication.

Pursuant to 37 C.F.R. 1.98(a)(2), Applicant believes that copies of cited U.S. Patents and Published Applications are no longer required to be provided to the Office. Notification of this change was provided in the United States Patent and Trademark Office OG Notices dated October 12, 2004. Thus, Applicant has not included copies of any US Patents or Published Applications cited with this submission. Should the Office require copies to be provided, Applicant respectfully requests that notice of such requirement be directed to Applicant's below-signed representative. Applicant acknowledges the requirement to submit copies of foreign patent documents and non-patent literature in accordance with 37 C.F.R. 1.98(a)(2).

Respectfully submitted,

ZHIPING YIN ET AL.

By their Representatives,

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Date January 31, 2006

By 
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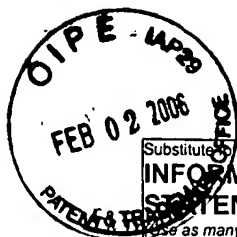
CERTIFICATE UNDER 37 CFR 1.8: The undersigned hereby certifies that this correspondence is being deposited with the United States Postal Service with sufficient postage as first class mail, in an envelope addressed to: MS Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on this 31 day of January, 2006.

Name

KATE GUNN

Signature





Substitute form 1449A/PTO

**INFORMATION DISCLOSURE
STATEMENT BY APPLICANT**

(Use as many sheets as necessary)

Complete if Known

Application Number	10/661,379
Filing Date	September 12, 2003
First Named Inventor	Yin, Zhiping
Group Art Unit	1756
Examiner Name	Rosasco, Stephen

Sheet 1 of 1

Attorney Docket No: 303.864US1

US PATENT DOCUMENTS

Examiner Initial *	USP Document Number	Publication Date	Name of Patentee or Applicant of cited Document	Filing Date If Appropriate
	US-2003/0198814 A1	10/23/2003	Khieu, S. S., et al.	04/23/2002
	US-2004/0092098 A1	05/13/2004	Sudijono, J., et al.	11/08/2002
	US-2006/0001175 A1	01/05/2006	Sandhu, G. S.	08/30/2005
	US-2006/0003237 A1	01/05/2006	Yin, Z., et al.	08/30/2005
	US-5,470,661	11/28/1995	Bailey, F. D., et al.	01/07/1993
	US-6,795,636	09/21/2004	Cronk, B. J., et al.	03/05/2000

FOREIGN PATENT DOCUMENTS

Examiner Initials*	Foreign Document No	Publication Date	Name of Patentee or Applicant of cited Document	T ²
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OTHER DOCUMENTS -- NON PATENT LITERATURE DOCUMENTS

Examiner Initials*	Cite No ¹	Include name of the author (in CAPITAL LETTERS), title of the article (when appropriate), title of the item (book, magazine, journal, serial, symposium, catalog, etc.), date, page(s), volume-issue number(s), publisher, city and/or country where published.	T ²
		CHEN, Z. Y., et al., "Optical Constants of Tetrahedral Amorphous Carbon Films in the Infrared Region and at a Wavelength of 633 nm", <u>Journal of Applied Physics</u> , Vol. 87 (9), American Institute of Physics, (May 1, 2000), 4268	
		HE, X., et al., "Characterization and Optical Properties of Diamondlike Carbon Prepared by Electron Cyclotron Resonance Plasma", <u>Journal of Materials Research</u> , vol. 14 (3), (Mar. 1999), 1055	
		LIDE, D. R., et al., "Physical Constants of Organic Compounds", <u>CRC Handbook of Chemistry and Physics</u> , Internet Version 2005, http://www.hbcnetbase.com , (2005), 12-157	
		ZHOU, X. T., et al., "Deposition and Properties of a-C:H films on Polymethyl Methacrylate by electron Cyclotron Resonance Microwave Plasma Chemical Vapor Deposition Method", <u>Surface and Coatings Technology</u> , 123, www.elsevier.nl/locate/surfcoat , (2000), 273-277	

EXAMINER

DATE CONSIDERED

Substitute Disclosure Statement Form (PTO-1449)

* EXAMINER: Initial if reference considered, whether or not citation is in conformance with MPEP 609. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant. ¹ Applicant's unique citation designation number (optional) ² Applicant is to place a check mark here if English language Translation is attached